



*DFW*

IOAP 4.1-1  
Appl. No. 10/526,800

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Appl. No.: 10/526,800 Confirmation No. 7409  
Applicant: Anatoly Leontievich Vikharev et al.  
Title: HIGH VELOCITY METHOD FOR DEPOSITING DIAMOND  
FILMS FROM A GASEOUS PHASE IN SHF DISCHARGE  
PLASMA AND DEVICE FOR CARRYING OUT SAID METHOD  
Filed: March 7, 2005  
TC/A.U.: 1792  
Examiner: Rakesh Kumar Dhingra  
Docket No.: IOAP 4.1-1 (000141527-0001)  
Customer No: 35684

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**INTERVIEW SUMMARY**

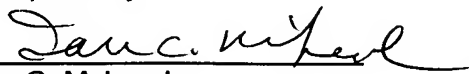
Sir:

As a result of a telephone call from Examiner Rakesh Dhingra, Claims 7, 8 and 14 were allowed. Attached is Claim 7 with the Amendment set forth in the Examiners Amendment. To further clarify the Examiners Amendment

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to Claim 7, on line 9 (of the attached claim) the words "at least" have been underlined.

Respectfully,

  
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